

論文 / 著書情報
Article / Book Information

Title(English)	Effects of deuterium density on the surface of the cathode on NPR
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Effects of cathode temperature on neutron production rate in inertial electrostatic confinement fusion

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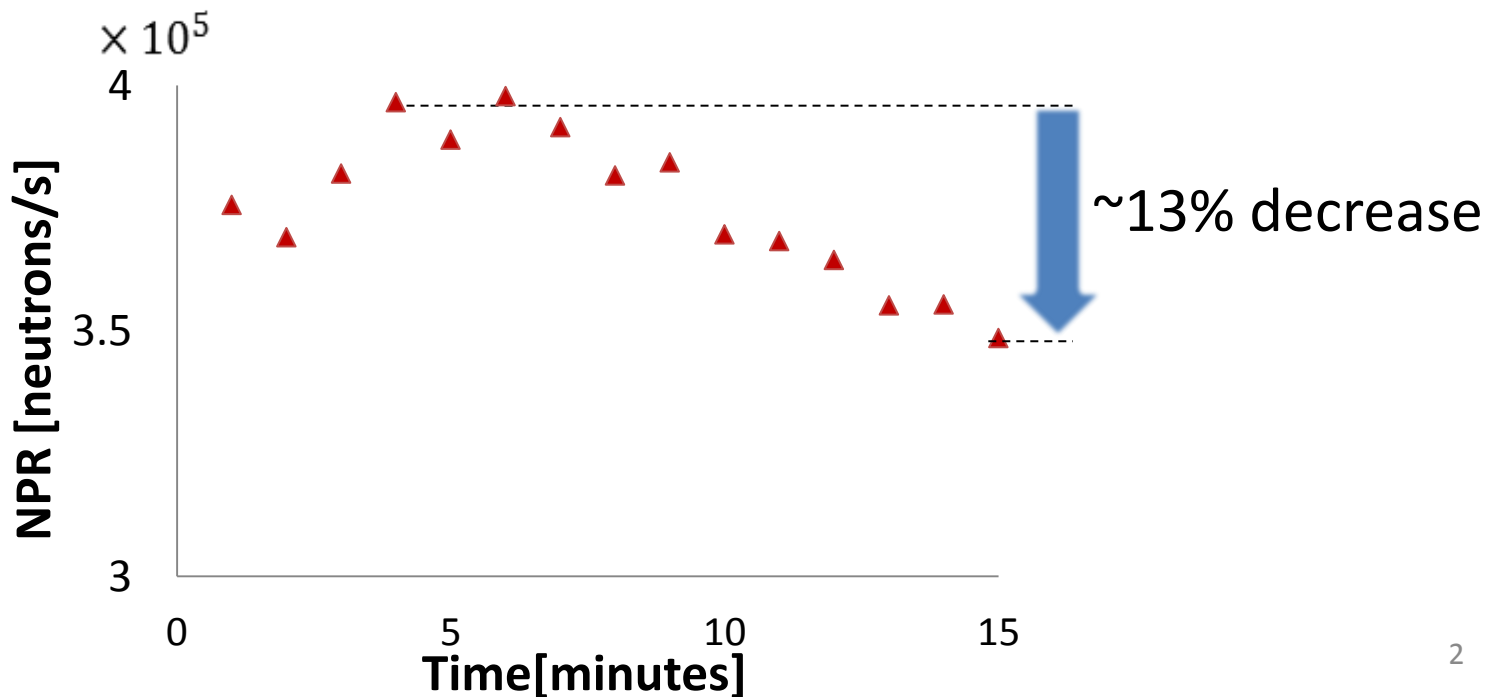
Motivation

NPR **decreases** as operating time **increases**



Problem for { NPR measurement
long period of time operation

NPR vs. Operating time@-20 kV 60 mA





Motivation 2

If we operate IECF device for a long period of time...

- Cathode temperature
 - Pressure
- } rises

Hypothesis

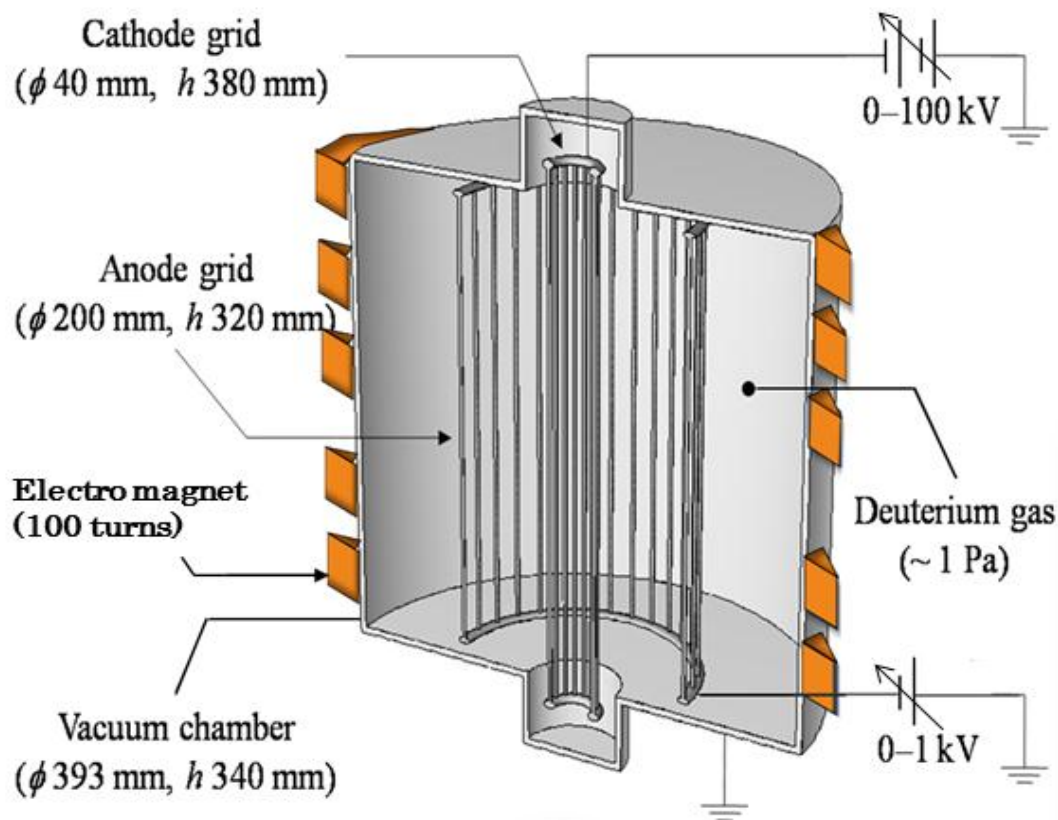
Cathode temperature affects **embedded fusion**

To prove the idea...

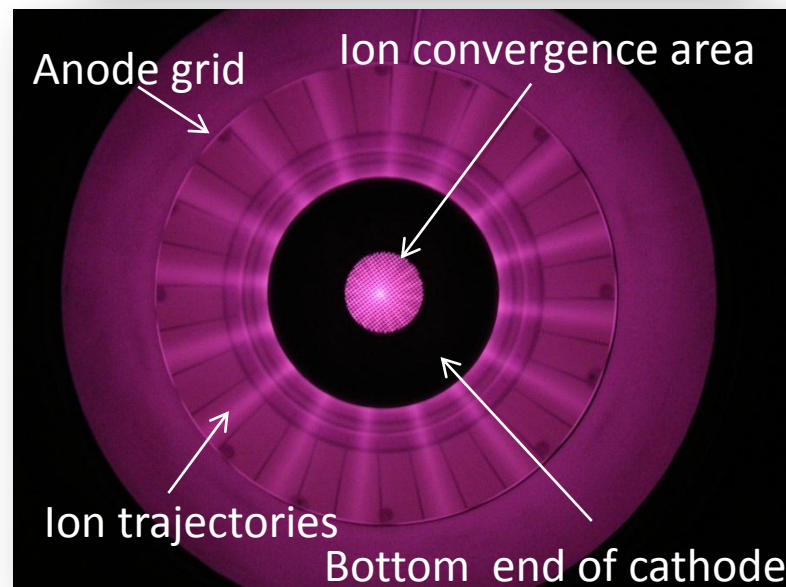
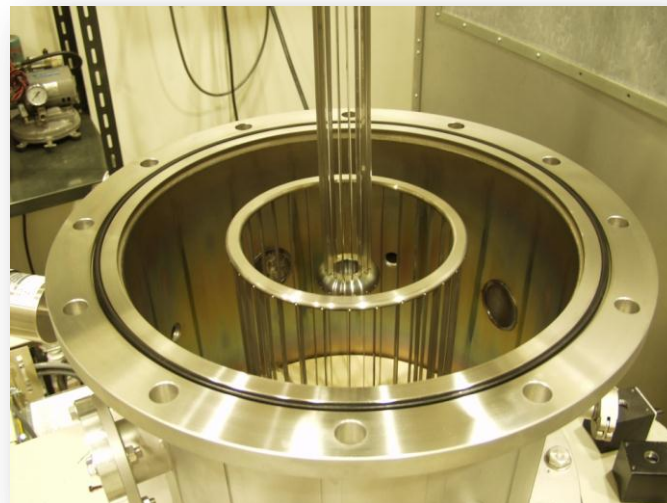
Cathode temperature was measured to calculate **deuteron density** on the surface of the cathode

Experimental setup

Cylindrical IECF device



Observing from a bottom side





Experimental setup 2

Radiation thermometer specs

Measurement range : 220~2000 °C

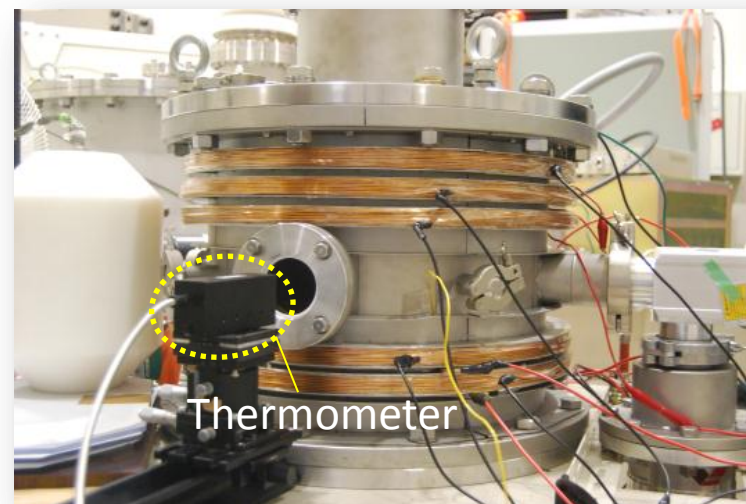
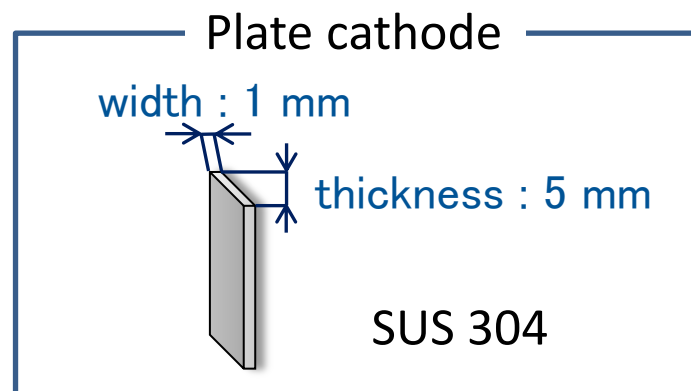
Wavelength 1.95~2 μm

Resolution : 3 °C

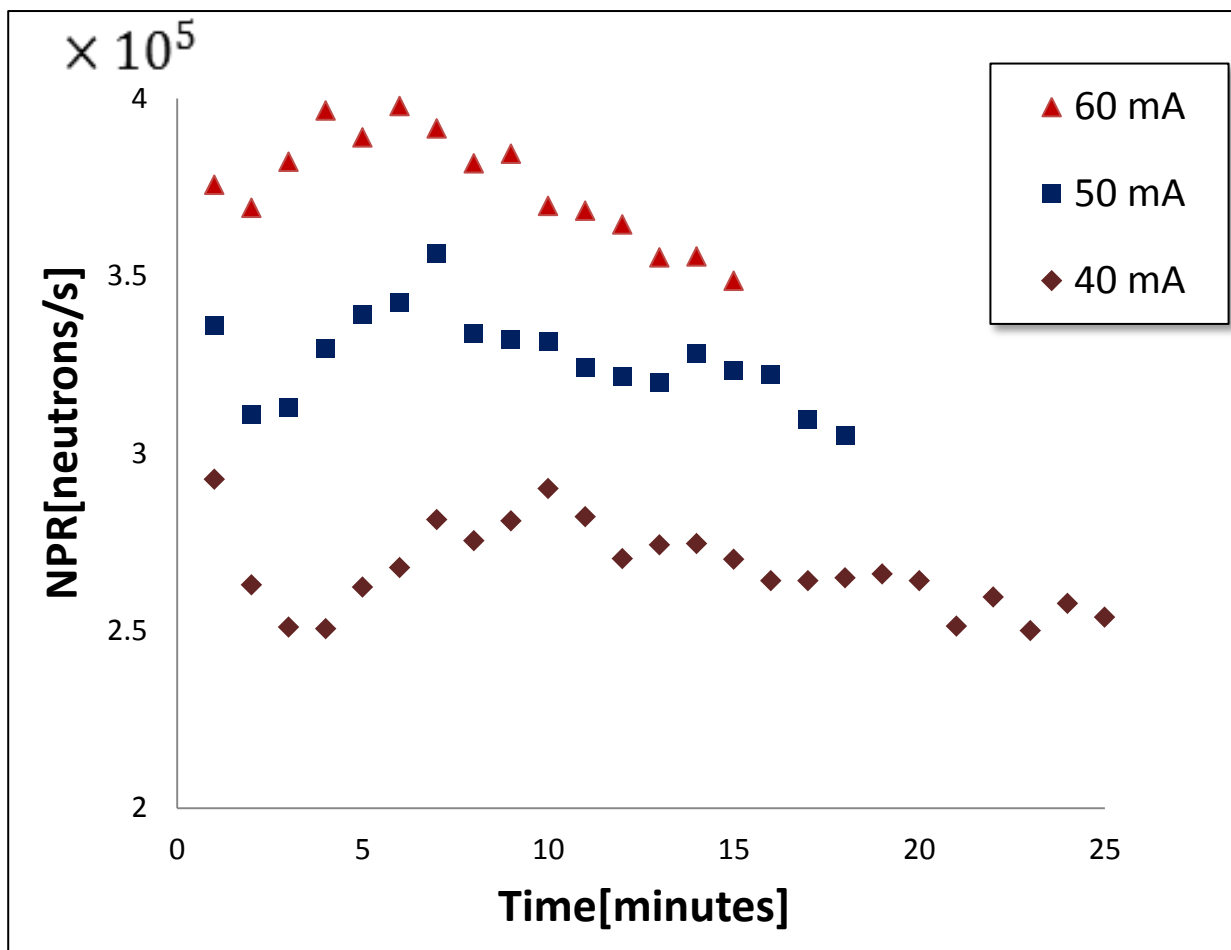
Measurement distance : 300 mm

Target diameter : 0.6 mm

- ✓ Emissivity was assumed as 0.74
- ✓ Plasma emission can be ignored



NPR @ -20 kV



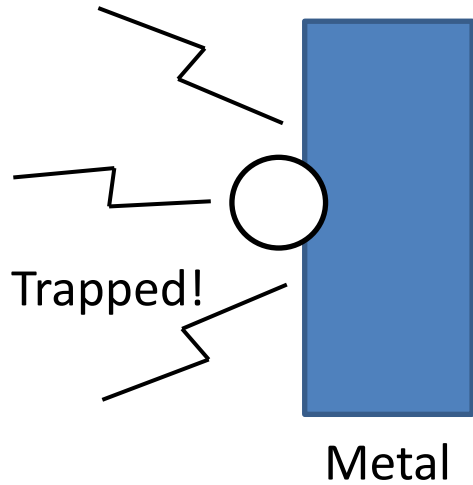
Higher input power makes the cathode hotter



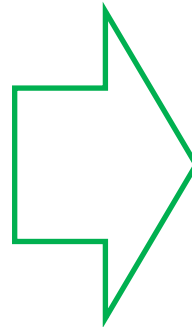
Cathode temperature affects NPR

Embedded fusion

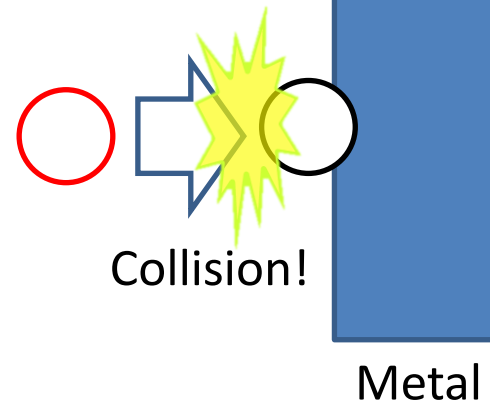
Step 1



○ : Particle of fusion gas



Step 2



○ : Fast particle



Relationship between NPR and deuteron density

Embedded fusion reaction rate R_{BM-C} can be described below

$$R_{BM-C} = \int_S \sigma n_{BM} \langle \Sigma v \rangle dS$$

σ : Deuteron density on the cathode

n_{BM} : Ion flux

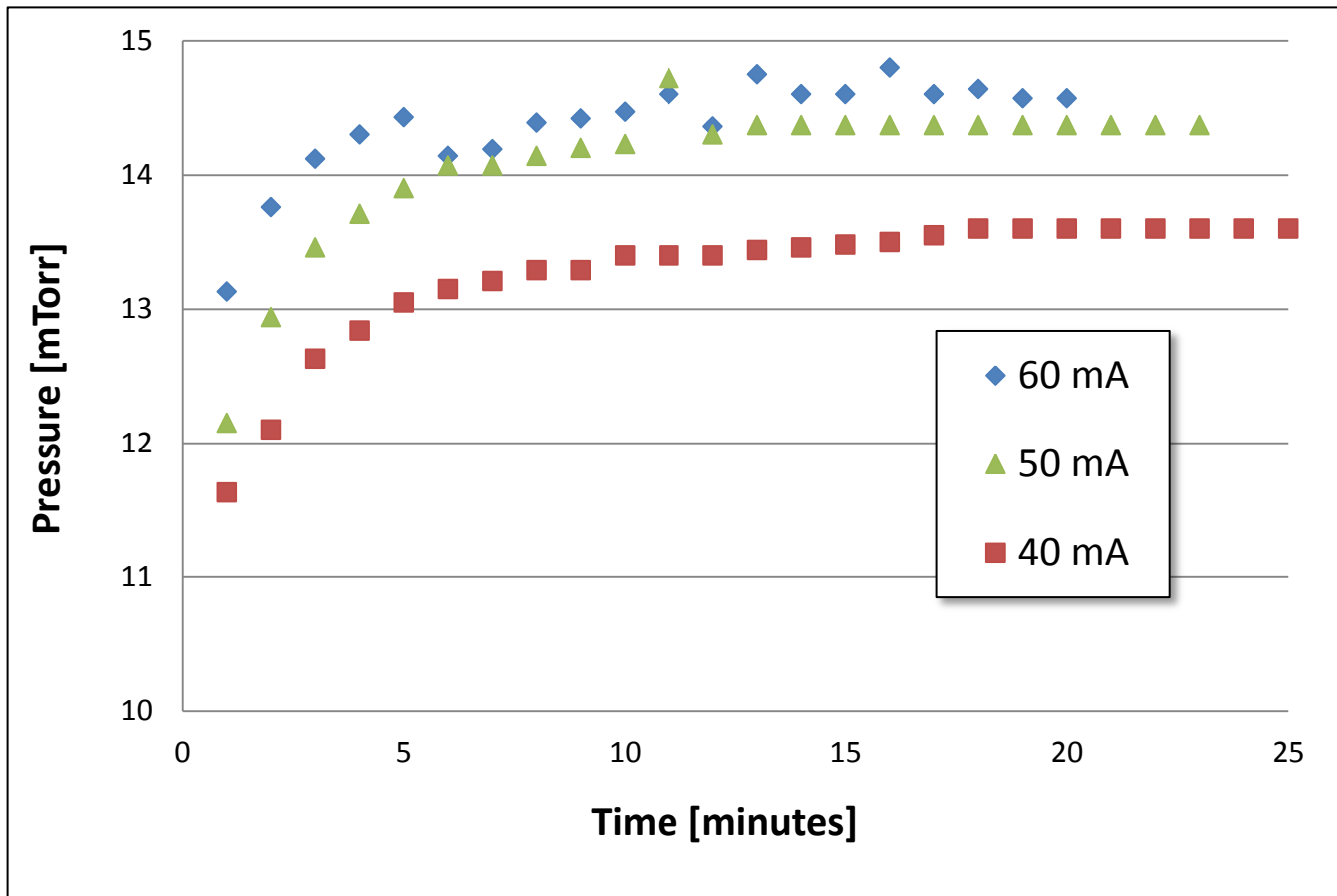
Σ : Cross section

v : relative velocity

R_{BM-C} increase and decrease can be estimated from σ

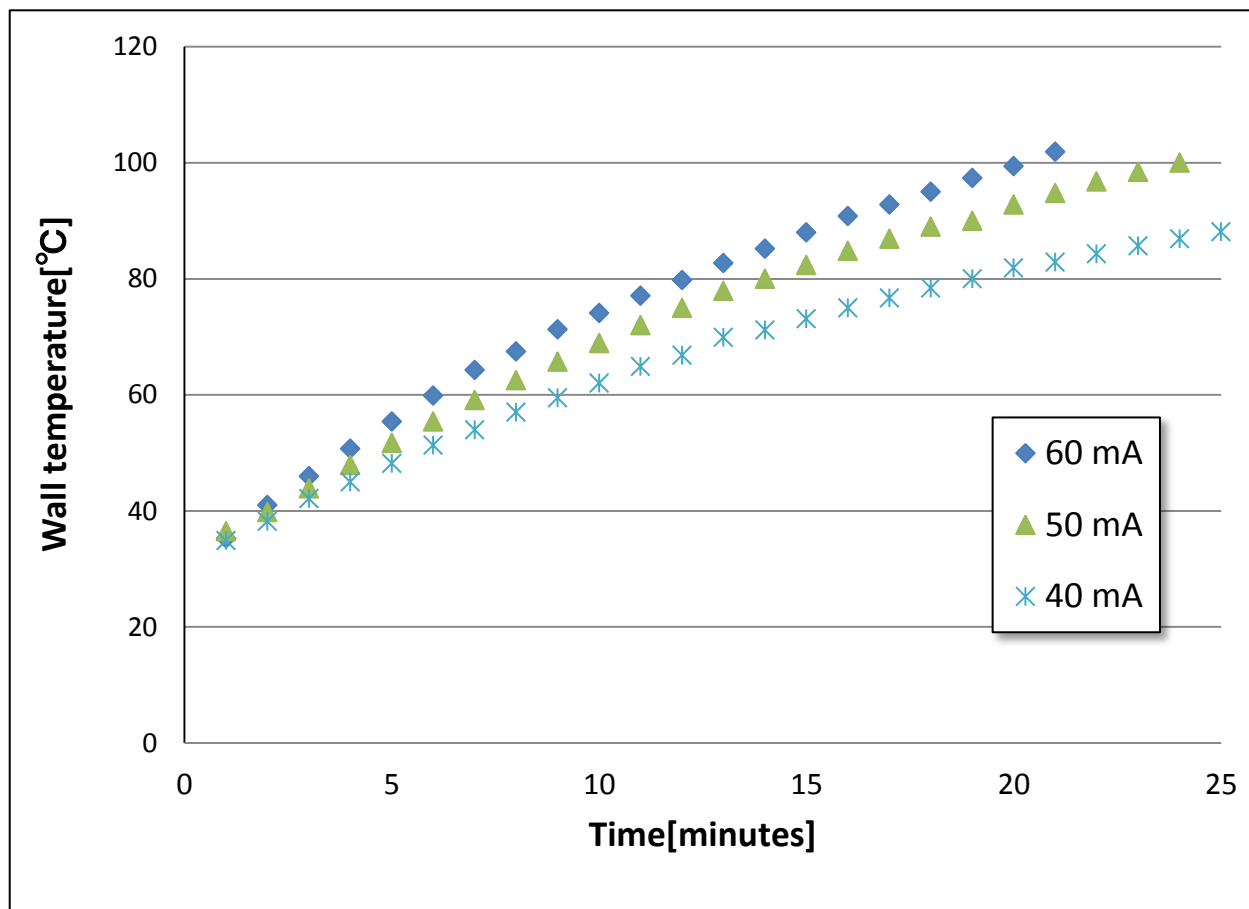
$$\frac{d\sigma}{dt} = \text{Implant}(I, T_{gas}, P) - \text{Desorption}(\sigma, T_{cathode})$$

Pressure @ -20 kV



Pressure rises about 10% in every current condition

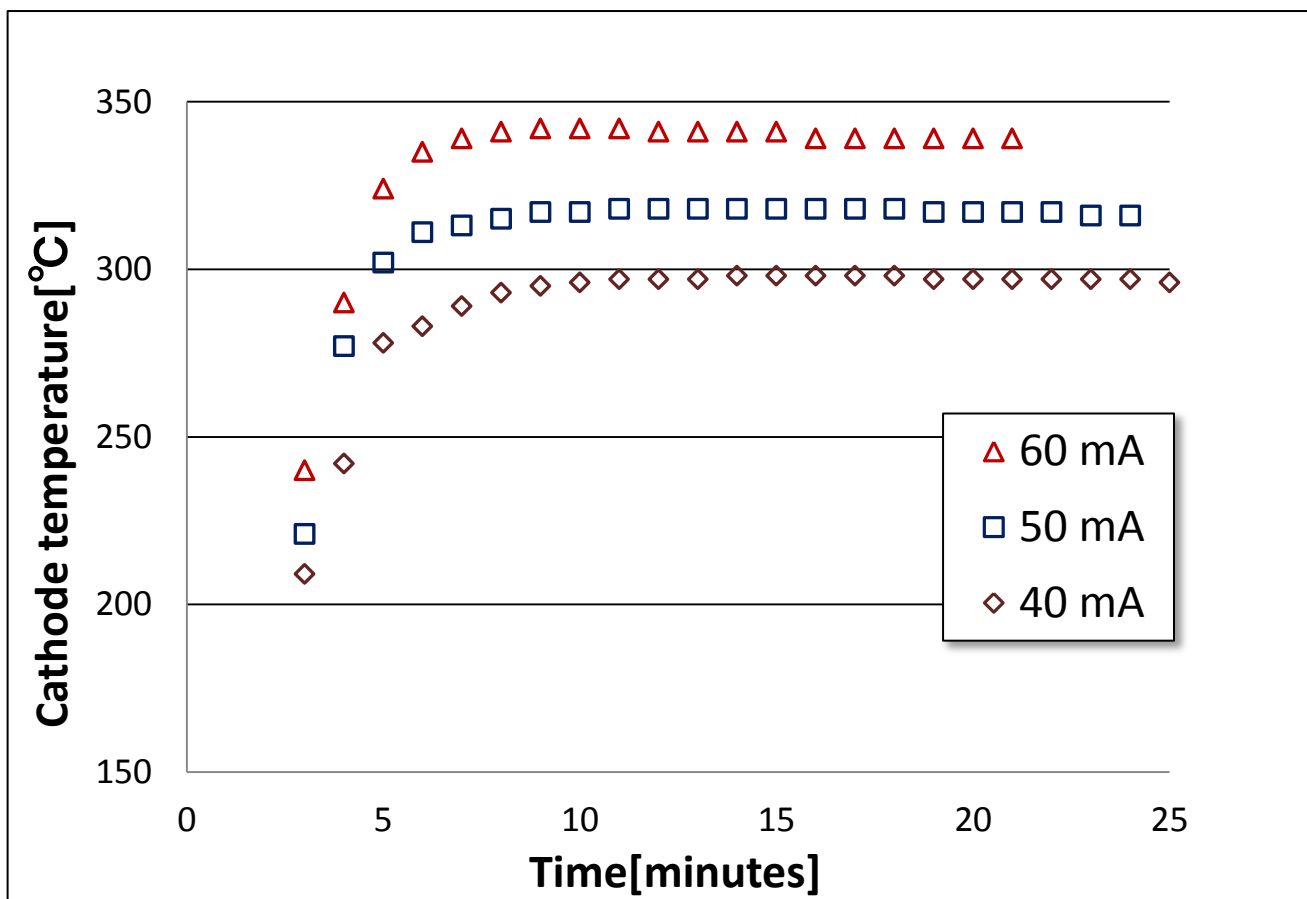
Gas temperature @-20 kV



We assumed device wall temperature as gas temperature



Cathode temperature @ -20 kV

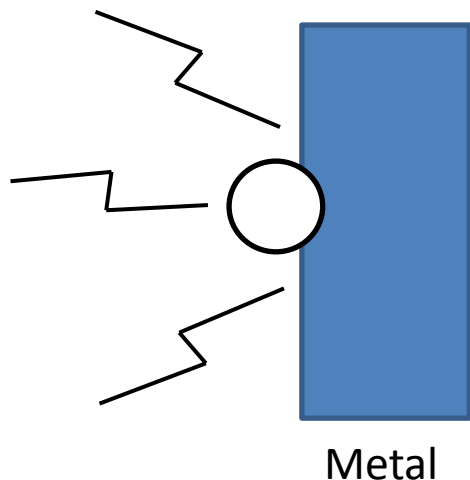


SUS(Cathode material)'s Melting point : about 1400 °C



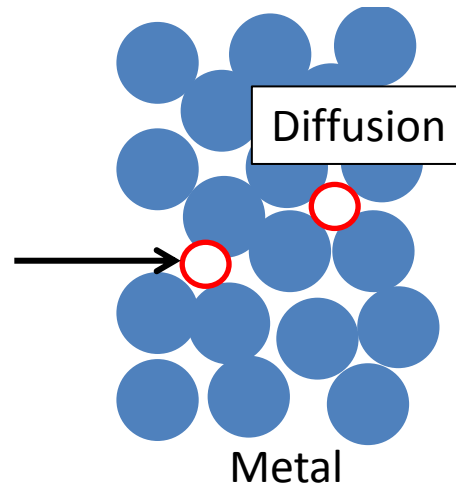
Deuterium trap on the cathode

Adsorption



○ : Background gas molecule

Embedment

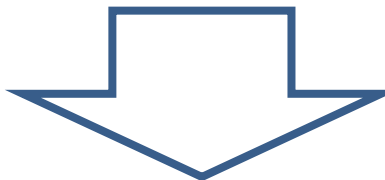


○ : Accelerated particle

- Physical adsorption
 - Van der waals attraction
 - Electro-static attraction
- Chemical adsorption
 - Ion binding

Adsorption

Adsorption speed can be described bellow

$$\left\{ \begin{array}{l} \frac{d\sigma}{dt} = \frac{1}{4} n \bar{v} s \\ \bar{v} = \sqrt{\frac{8kT}{\pi m}} = \sqrt{\frac{8RT}{\pi M}} \end{array} \right.$$


σ : Deuterium density
 n : Molecule density
 $\bar{v}$: Average velocity of molecules
 T : Gas temperature
 s : Adsorption rate
 k : Boltzmann constant
 m : Mass of molecules
 M : Molecular weight
 R : Gas constant
 p : pressure

$$\frac{d\sigma}{dt} = 3.5 \times 10^{22} \frac{sp}{\sqrt{MT_{gas}}} \quad p \text{ [Torr]}, T_{gas} \text{ [K]}$$



Embedment

Assuming Γ_{beam} as ion flux to the cathode,
embedment speed can be described bellow

$$\frac{d\sigma}{dt} = A\Gamma_{beam}$$

$$\Gamma_{beam} = \frac{I}{CS} \times \frac{1}{1 + \gamma}$$

σ : Deuterium density

A : Ion embedment rate

I : Cathode current

C : Elementary charge

S : Area of the cathode

γ : second electron emission coefficient

We assumed $A = 0.25$ and $\gamma = 1$

$$\frac{d\sigma}{dt} = 7.8 \times 10^{14} \frac{I}{S}$$

Adsorption $\approx 10^{19}$

Embedment $\approx 10^{15}$

This effect could be stronger in spherical device



Desorption

Desorption speed can be described below

$$-\frac{d\sigma}{dt} = -\sigma\nu \exp\left(-\frac{E_d}{RT_{Cathode}}\right)$$

σ : Deuterium density

ν : Desorption reaction constant

E_d : Activation energy of desorption

R : Gas constant

$T_{Cathode}$: Cathode temperature

Hydrogen – Tungsten desorption

$$-\frac{d\sigma}{dt} = -\sigma \times 2.2 \times 10^{13} \exp\left(\frac{-67 \times 10^3}{RT_C}\right)$$



Summary of calculation

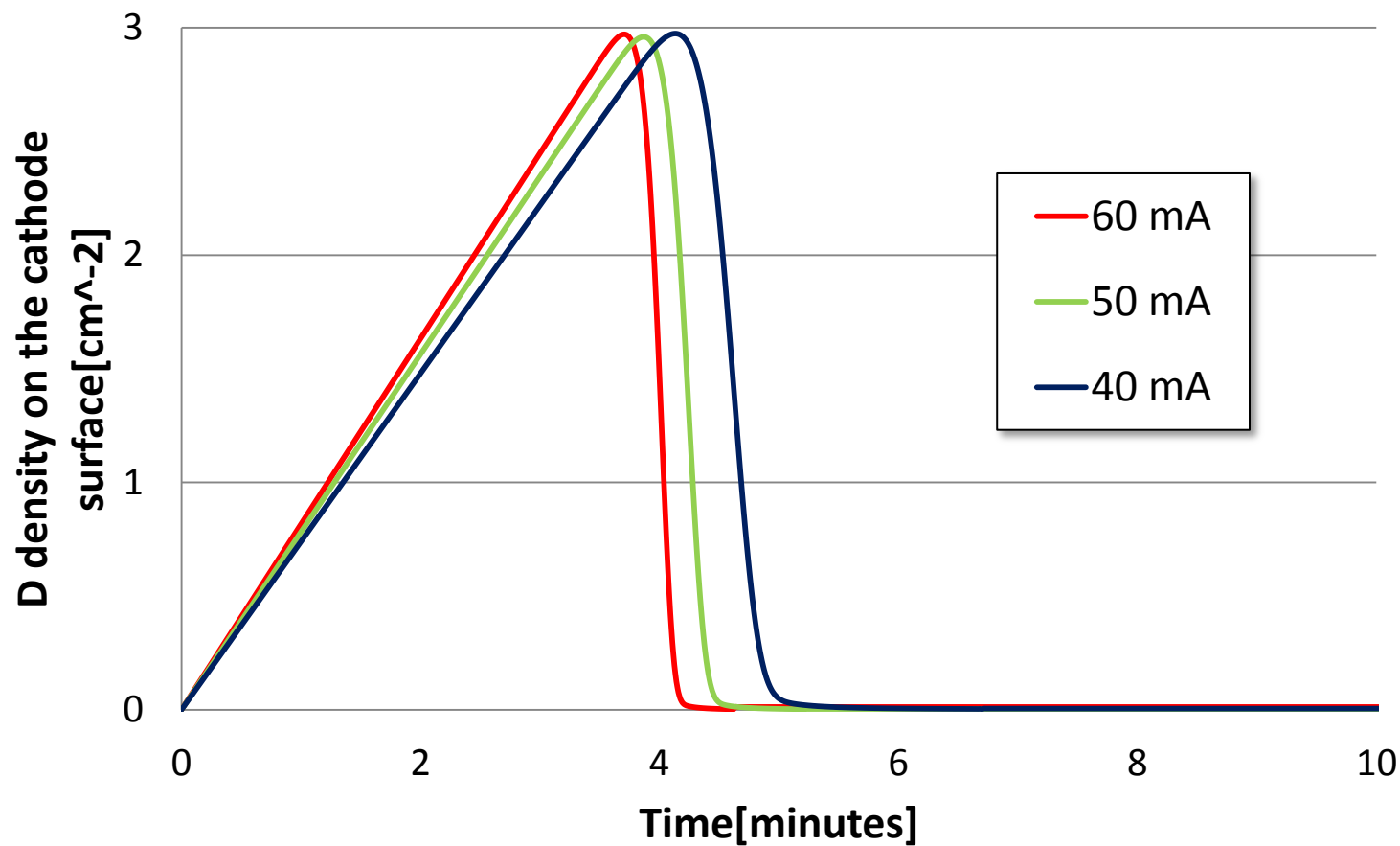
$$\frac{d\sigma}{dt} = 3.5 \times 10^{22} \frac{sp}{\sqrt{MT_{gas}}} + 7.8 \times 10^{14} \frac{I}{S} - \sigma$$

$$\times 2.2 \times 10^{13} \exp\left(\frac{-67 \times 10^3}{RT_c}\right)$$

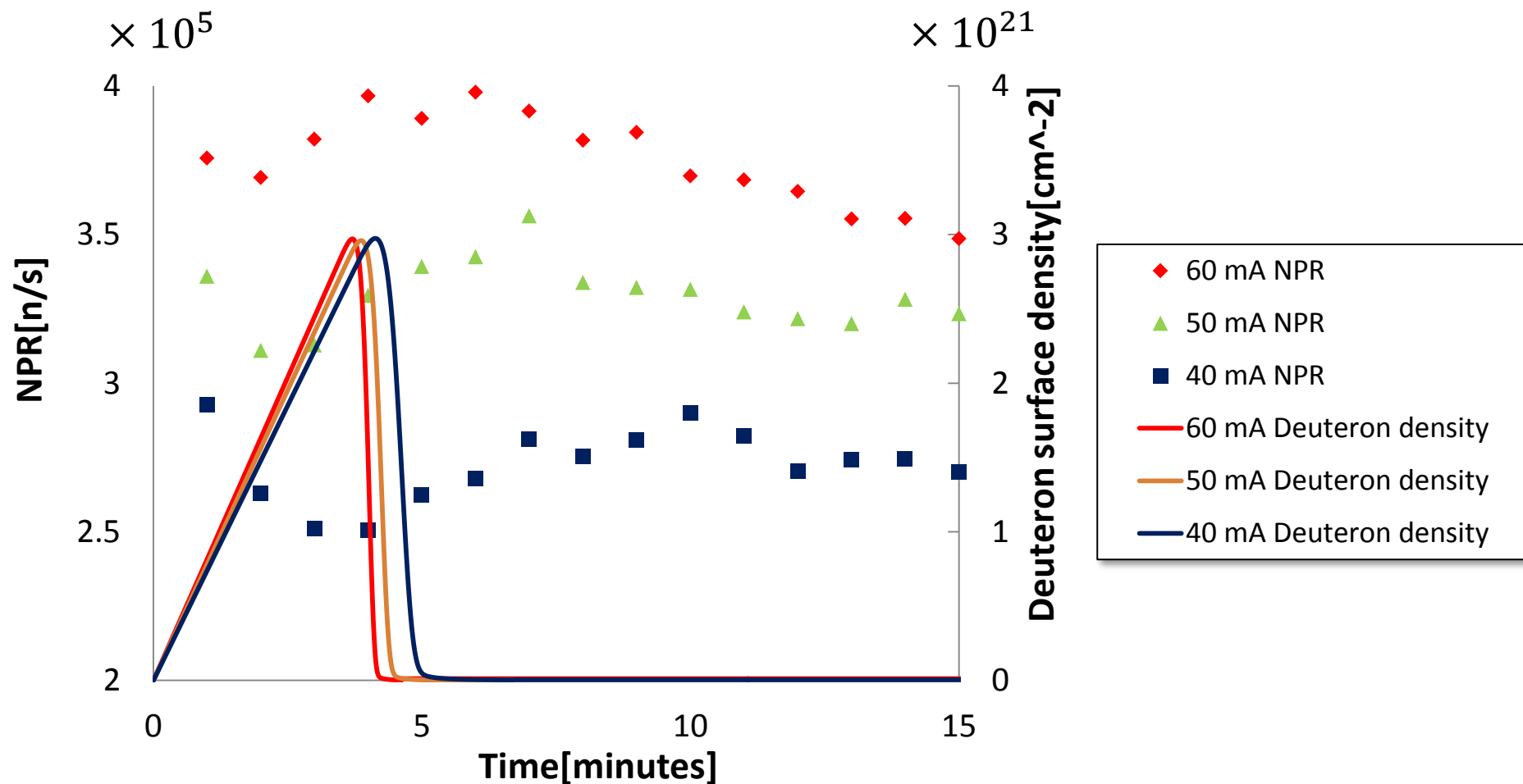
We assumed $s=0.1$ and $\sigma(0)=0$

Value of s was said $0.1 \sim 1$ in reference

Result



Deuteron density and NPR vs. time



How should we measure NPR?



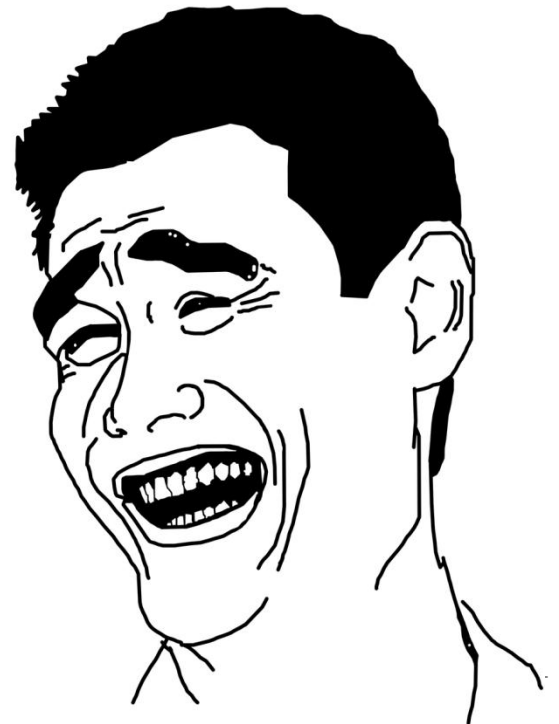
We should run a IECF device until NPR become stable
Measurement of NPR should be done after that

Summary

- ✓ Introduced how to calculate deuteron density on the cathode.
- ✓ NPR vs. time tendency can be explained by embedded fusion on some level.

Any questions or suggestions?

Speak slowly, use easy word plz ;)



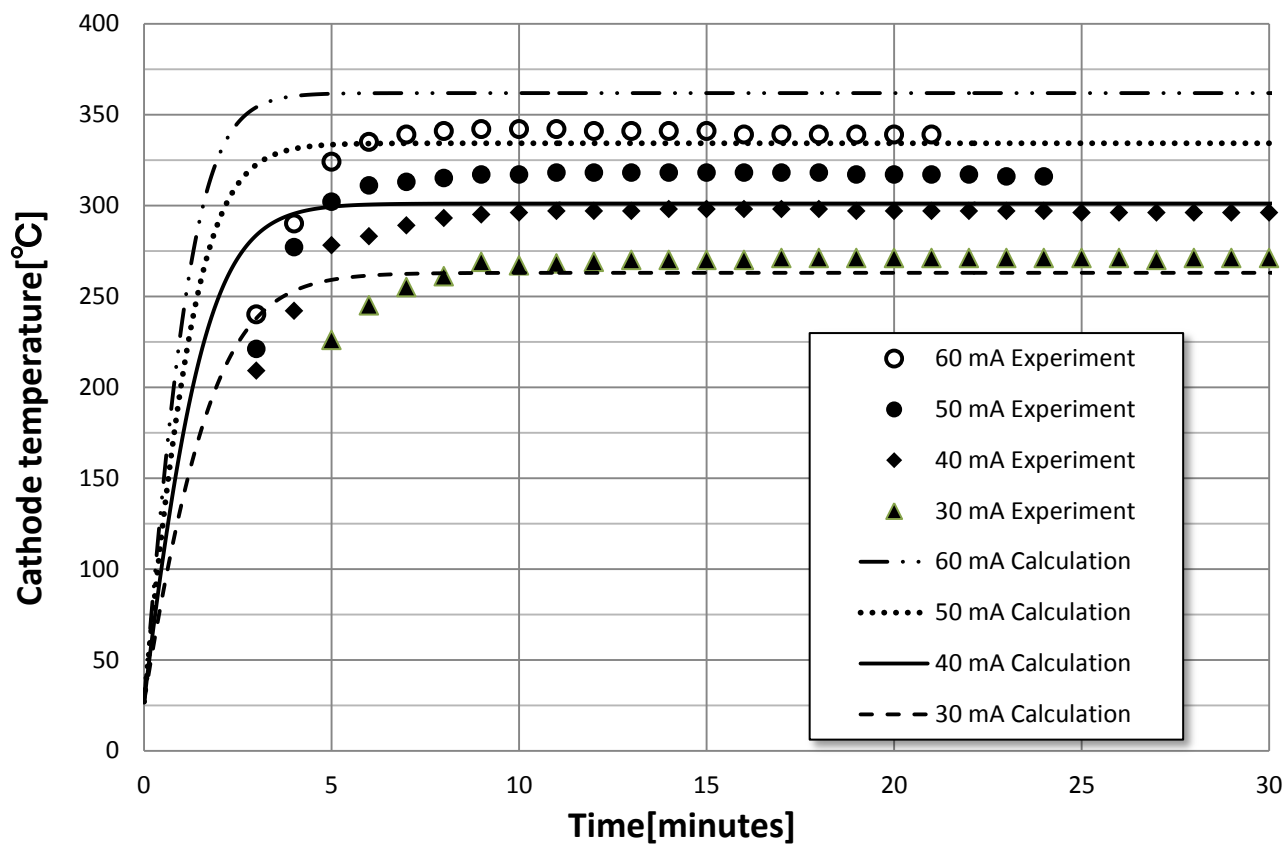


Reference

H.Kumagai, G.Tominaga : 「真空の物理と応用(Vacuum physics and applications)」

↓ Appendix

Temperature calculation



Pulse operation

